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CONFIRMATION NO. 3611

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| SERIAL NUMBER 10/550,855 | FILING or 371(c) DATE 09/18/2006 RULE | CLASS 118 | GROUP ART UNIT 2813 | ATTORNEY DOCKET NO. PUS-E005-013 | |
| APPLICANTS Hans Von Kaenel, Zurich, SWITZERLAND; ** CONTINUING DATA ***** This application is a 371 of PCT/EP03/03136 03/26/2003 ** FOREIGN APPLICATIONS ***** ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ** 09/26/2006 | | | | | |
| Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /SONYA D MCCALL SHEPARD/ Acknowledged Examiner's Signature | <input type="checkbox"/> Met after Allowance Initials | STATE OR COUNTRY SWITZERLAND | SHEETS DRAWINGS 6 | TOTAL CLAIMS 23 | INDEPENDENT CLAIMS 2 |
| ADDRESS MOETTELI & ASSOCIATES SARL ST. LEONHARDSTRASSE 4 ST. GALLEN, CH-9000 SWITZERLAND | | | | | |
| TITLE Formation of thin semiconductor layers by low-energy plasma enhanced chemical vapor deposition and semiconductor heterostructure devices | | | | | |
| FILING FEE RECEIVED 590 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |